



AMAT CENTURA 5200 CVD SYSTEM

Manufacturer:	Applied Materials
Model:	Centura 5200
Vintage:	
Wafer Size:	200mm (8")
Serial Number:	2851
Process:	DxZ PE Silane, SACVD
Configuration:	Widebody loadlocks HP robot OTF Seriplex gas panel, 2 chambers Position A : DxZ PE Silane Position C: DxZ SACVD, Top RPS Position E: MSCD Position F: Orienter AX8200A ozone generator rack Neslab HX-300 chiller Amat O heat exchanger Excellent condition

